







DLP4710LC

ZHCSLB6C - MAY 2020 - REVISED JULY 2023

DLP4710LC 0.47 1080p 数字微镜器件

1 特性

- 0.47 英寸 (11.93mm) 对角线微镜阵列
 - 1920 × 1080 铝制微米级微镜阵列,采用正交布
 - 微镜间距:5.4 μ m
 - 微镜倾斜(相对于平坦表面):±17°
 - 底部照明,实现最优的效率和光学引擎尺寸
 - 偏振无关型铝微镜表面
- 32 位 SubLVDS 输入数据总线
- 专用 DLP3479 显示和光控制器
- 专用 DLPA3000 或 DLPA3005 PMIC/LED 驱动器 确保可靠运行

2 应用

- 3D 深度捕捉: 3D 相机、3D 重建、牙科扫描仪
- 3D 机器视觉:机器人学、计量学、自动直列式检测 (AOI)
- 3D 生物特征识别:人脸和指纹识别
- 集成显示和 3D 深度捕捉:投影映射、智能照明、
 - AR 投影
- 曝光:可编程空间和时间曝光

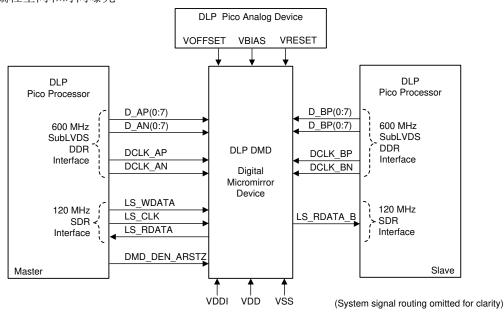
3 说明

DLP4710LC 数字微镜器件 (DMD) 是一款数控微光机 电系统 (MOEMS) 空间照明调制器 (SLM)。当与适当的 光学系统配合使用时, DLP4710LC DMD 可显示非常 清晰的高质量图像或视频。此器件是 DLP4710LC DMD、DLPC3479 控制器和 DLPA3000/DLPA3005 驱动器所组成的芯片组的组件。 PMIC/LED DLP4710LC 外形小巧,与控制器和 PMIC/LED 驱动器 共同组成完整的系统解决方案,从而实现小尺寸、低功 耗和高分辨率的高清显示产品。

哭件信息

| | HH ; ; | 14.0 |
|-----------|-------------------|----------------|
| 器件型号 | 封装 ⁽¹⁾ | 封装尺寸(标称值) |
| DLP4710LC | FQL (100) | 24.50mm × 11mm |

如需了解所有可用封装,请参阅数据表末尾的可订购产品附



0.47 1080p 芯片组



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4 Revision History

注:以前版本的页码可能与当前版本的页码不同

| Changes from Revision B (May 2022) to Revision C (July 2023) | Page |
|---|-----------|
| Added "ILLUMINATION" to Recommended Operating Conditions | |
| Updated Micromirror Array Temperature Calculation | |
| Added Micromirror Power DensityCalculation | 28 |
| Changes from Revision A (October 2021) to Revision B (May 2022) | Page |
| Updated Absolute Maximum Ratings disclosure to the latest TI standard | 8 |
| | |
| Updated Micromirror Array Optical Characteristics | <u>22</u> |

Product Folder Links: DLP4710LC



5 Pin Configuration and Functions

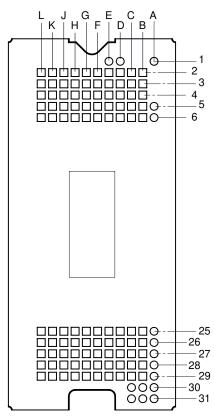


图 5-1. FQL Package 100-Pin LGA Bottom View

表 5-1. Pin Functions - Connector Pins

| PIN ⁽¹⁾ | | | | The directions | | PACKAGE NET |
|--------------------|-----|------|---------|----------------|----------------|----------------------------|
| NAME | NO. | TYPE | SIGNAL | DATA RATE | DESCRIPTION | LENGTH ⁽²⁾ (mm) |
| DATA INPUTS | | | | | | |
| D_AN(0) | G3 | I | SubLVDS | Double | Data, Negative | 5.01 |
| D_AN(1) | F4 | 1 | SubLVDS | Double | Data, Negative | 2.03 |
| D_AN(2) | E3 | ı | SubLVDS | Double | Data, Negative | 2.41 |
| D_AN(3) | E6 | ı | SubLVDS | Double | Data, Negative | 4.71 |
| D_AN(4) | J5 | I | SubLVDS | Double | Data, Negative | 3.23 |
| D_AN(5) | L5 | I | SubLVDS | Double | Data, Negative | 3.87 |
| D_AN(6) | G5 | I | SubLVDS | Double | Data, Negative | 6.32 |
| D_AN(7) | L3 | ı | SubLVDS | Double | Data, Negative | 1.84 |
| D_AP(0) | НЗ | I | SubLVDS | Double | Data, Positive | 5.01 |
| D_AP(1) | G4 | I | SubLVDS | Double | Data, Positive | 2.03 |
| D_AP(2) | E4 | I | SubLVDS | Double | Data, Positive | 2.41 |
| D_AP(3) | E5 | I | SubLVDS | Double | Data, Positive | 4.71 |
| D_AP(4) | J6 | ı | SubLVDS | Double | Data, Positive | 3.23 |
| D_AP(5) | L6 | I | SubLVDS | Double | Data, Positive | 3.87 |
| D_AP(6) | G6 | I | SubLVDS | Double | Data, Positive | 6.32 |
| D_AP(7) | L4 | ı | SubLVDS | Double | Data, Positive | 1.84 |
| D_BN(0) | G27 | I | SubLVDS | Double | Data, Negative | 2.51 |



表 5-1. Pin Functions - Connector Pins (continued)

| PIN ⁽¹⁾ | PIN ⁽¹⁾ PIN ⁽¹⁾ PIN ⁽¹⁾ PACKAGE NET | | | | | | | |
|--------------------|--|-------|----------------------|-----------|--|----------------------------|--|--|
| NAME | NO. | TYPE | SIGNAL | DATA RATE | DESCRIPTION | LENGTH ⁽²⁾ (mm) | | |
| D_BN(1) | E26 | l | SubLVDS | Double | Data, Negative | 4.43 | | |
| D_BN(2) | D28 | ı | SubLVDS | Double | Data, Negative | 2.76 | | |
| D_BN(3) | D26 | ı | SubLVDS | Double | Data, Negative | 5.47 | | |
| D_BN(4) | L25 | ı | SubLVDS | Double | Data, Negative | 4.85 | | |
| D_BN(5) | K25 | Į | SubLVDS | Double | Data, Negative | 4.10 | | |
| D_BN(6) | L28 | I | SubLVDS | Double | Data, Negative | 2.53 | | |
| D_BN(7) | K27 | Į | SubLVDS | Double | Data, Negative | 2.76 | | |
| D_BP(0) | F27 | I | SubLVDS | Double | Data, Positive | 2.51 | | |
| D_BP(1) | E27 | I | SubLVDS | Double | Data, Positive | 4.43 | | |
| D_BP(2) | D27 | I | SubLVDS | Double | Data, Positive | 2.76 | | |
| D_BP(3) | D25 | I | SubLVDS | Double | Data, Positive | 5.47 | | |
| D_BP(4) | L26 | I | SubLVDS | Double | Data, Positive | 4.85 | | |
| D_BP(5) | J25 | I | SubLVDS | Double | Data, Positive | 4.10 | | |
| D_BP(6) | K28 | ı | SubLVDS | Double | Data, Positive | 2.53 | | |
| D_BP(7) | J27 | ı | SubLVDS | Double | Data, Positive | 2.76 | | |
| DCLK_AN | J3 | I | SubLVDS | Double | Clock, Negative | 3.77 | | |
| DCLK_AP | K3 | I | SubLVDS | Double | Clock, Positive | 3.77 | | |
| DCLK_BN | H26 | I | SubLVDS | Double | Clock, Negative | 2.98 | | |
| DCLK_BP | H27 | I | SubLVDS | Double | Clock, Positive | 2.98 | | |
| CONTROL INPUTS | | | 1 | | | | | |
| LS_WDATA | D3 | Į | LPSDR ⁽¹⁾ | Single | Write data for low speed interface. | 1.20 | | |
| LS_CLK | C3 | I | LPSDR | Single | Clock for low-speed interface | 1.20 | | |
| DMD_DEN_ARSTZ | В6 | I | LPSDR | | Asynchronous reset DMD signal. A low signal places the DMD in reset. A high signal releases the DMD from reset and places it in active mode. | 4.19 | | |
| LS_RDATA_A | C6 | 0 | LPSDR | Single | Read data for low-speed interface | 3.93 | | |
| LS_RDATA_B | C4 | 0 | LPSDR | Single | Read data for low-speed interface | 2.57 | | |
| POWER (3) | | | 1 | | | | | |
| VBIAS | B27 | Power | | | Supply voltage for positive bias level at | 24.51 | | |
| VBIAS | B4 | Power | | | micromirrors | 24.51 | | |
| VOFFSET | B2 | Power | | | Supply voltage for HVCMOS core | 49.56 | | |
| VOFFSET | C29 | Power | | | logic. Supply voltage for stepped high level at micromirror address electrodes. Supply voltage for offset level at micromirrors. | 49.56 | | |
| VRESET | B28 | Power | | | Supply voltage for negative reset level | 24.82 | | |
| VRESET | В3 | Power | | | at micromirrors. | 24.82 | | |

表 5-1. Pin Functions - Connector Pins (continued)

| PIN ⁽¹⁾ | TYPE | SIGNAL | DATA DATE DESCRIPTION | DESCRIPTION | PACKAGE NET | |
|--------------------|------|--------|-----------------------|---|--|----------------------------|
| NAME | NO. | ITPE | SIGNAL | DATA RATE | DESCRIPTION | LENGTH ⁽²⁾ (mm) |
| VDD | C2 | Power | | | | |
| VDD | D2 | Power | | | | |
| VDD | D29 | Power | | | | |
| VDD | E2 | Power | | | | |
| VDD | E29 | Power | | | | |
| VDD | H2 | Power | | | Supply voltage for LVCMOS core logic Supply voltage for LPSDR inputs. | |
| VDD | H28 | Power | | | | |
| VDD | H29 | Power | | | Supply voltage for LPSDR inputs. Supply voltage for normal high level at | |
| VDD | J2 | Power | | Supply voltage for normal high level at micromirror address electrodes. | | |
| VDD | J28 | Power | | | | |
| VDD | J29 | Power | | | | |
| VDD | K2 | Power | | | | |
| VDD | K29 | Power | | | | |
| VDD | L2 | Power | | | | |
| VDD | L29 | Power | | | | |
| VDDI | E28 | Power | | | | |
| VDDI | F2 | Power | | | | |
| VDDI | F28 | Power | | | | |
| VDDI | F29 | Power | | | Complex colleges for College VDC reconstruction | |
| VDDI | F3 | Power | | | Supply voltage for SubLVDS receivers. | |
| VDDI | G2 | Power | | | | |
| VDDI | G28 | Power | | | | |
| VDDI | G29 | Power | | | | |



表 5-1. Pin Functions - Connector Pins (continued)

| PIN ⁽¹⁾ | | | -1. 1 III 1 UII | | | PACKAGE NET |
|--------------------|-----|--------|-----------------|-----------|-----------------------|----------------------------|
| NAME | NO. | TYPE | SIGNAL | DATA RATE | DESCRIPTION | LENGTH ⁽²⁾ (mm) |
| VSS | B25 | Ground | | | | |
| VSS | B26 | Ground | | | | |
| VSS | B29 | Ground | | | | |
| VSS | B5 | Ground | | | | |
| VSS | C25 | Ground | | | | |
| VSS | C26 | Ground | | | | |
| VSS | C27 | Ground | | | | |
| VSS | C28 | Ground | | | | |
| VSS | C5 | Ground | | | | |
| VSS | D4 | Ground | | | | |
| VSS | D5 | Ground | | | | |
| VSS | D6 | Ground | | | | |
| VSS | E25 | Ground | | | | |
| VSS | F25 | Ground | | | | |
| VSS | F26 | Ground | | | Common return. | |
| VSS | F5 | Ground | | | Ground for all power. | |
| VSS | F6 | Ground | | | | |
| VSS | G25 | Ground | | | | |
| VSS | G26 | Ground | | | | |
| VSS | H25 | Ground | | | | |
| VSS | H4 | Ground | | | | |
| VSS | H5 | Ground | | | | |
| VSS | H6 | Ground | | | | |
| VSS | J26 | Ground | | | | |
| VSS | J4 | Ground | | |] | |
| VSS | K26 | Ground | | | | |
| VSS | K4 | Ground | | |] | |
| VSS | K5 | Ground | | | | |
| VSS | K6 | Ground | | | | |
| VSS | L27 | Ground | | |] | |

- (1) Low speed interface is LPSDR and adheres to the Electrical Characteristics and AC/DC Operating Conditions table in JEDEC Standard No. 209B, Low Power Double Data Rate (LPDDR) JESD209B.
- (2) Net trace lengths inside the package:
 - Relative dielectric constant for the FQL ceramic package is 9.8.
 - Propagation speed = 11.8 / sqrt (9.8) = 3.769 inches/ns.
 - Propagation delay = 0.265 ns/inch = 265 ps/inch = 10.43 ps/mm.
- (3) The following power supplies are all required to operate the DMD: VDD, VDDI, VOFFSET, VBIAS, VRESET. All VSS connections are also required.

Product Folder Links: DLP4710LC



表 5-2. Pin Functions - Test Pads

| 1 0-2. I III I UII | Clions restrates |
|--------------------|------------------|
| NUMBER | SYSTEM BOARD |
| A1 | Do not connect |
| A5 | Do not connect |
| A6 | Do not connect |
| A25 | Do not connect |
| A26 | Do not connect |
| A27 | Do not connect |
| A28 | Do not connect |
| A29 | Do not connect |
| A30 | Do not connect |
| A31 | Do not connect |
| B30 | Do not connect |
| B31 | Do not connect |
| C30 | Do not connect |
| C31 | Do not connect |
| D1 | Do not connect |
| E1 | Do not connect |



6 Specifications

6.1 Absolute Maximum Ratings

see (1)

| | | | MIN | MAX | UNIT |
|---|---|--|--|---------------|------|
| | VDD | Supply voltage for LVCMOS core logic ⁽²⁾ Supply voltage for LPSDR low speed interface | - 0.5 | 2.3 | V |
| | VDDI | Supply voltage for SubLVDS receivers ⁽²⁾ | - 0.5 | 2.3 | V |
| | VOFFSET | Supply voltage for HVCMOS and micromirror electrode ^{(2) (3)} | - 0.5 | 11 | V |
| | VBIAS | Supply voltage for micromirror electrode ⁽²⁾ | - 0.5 | 19 | V |
| Supply voltage for LPSDR low speed interface VDDI Supply voltage for SubLVDS receivers ⁽²⁾ VOFFSET Supply voltage for HVCMOS and micromirror electrode ^{(2) (3)} | - 15 | 0.5 | V | | |
| | VDDI - VDD | Supply voltage delta (absolute value) ⁽⁴⁾ | | 0.3 | V |
| | ļ · | Supply voltage delta (absolute value) ⁽⁵⁾ | | 11 | V |
| | 1 | Supply voltage delta (absolute value) ⁽⁶⁾ | | 34 | V |
| | Input voltage for | other inputs LPSDR ⁽²⁾ | - 0.5 | VDD + 0.5 | V |
| Input voltage Input pins Clock frequency | Input voltage for | other inputs SubLVDS ^{(2) (7)} | - 0.5 | VDDI + 0.5 | V |
| Input voltage | VID | SubLVDS input differential voltage (absolute value) ⁽⁷⁾ | | 810 | mV |
| Imput pins | IID | SubLVDS input differential current | - 0.5 19 - 15 0.5 0.3 11 34 - 0.5 VDD + 0.5 - 0.5 VDDI + 0.5 810 10 130 620 - 20 90 - 40 90 81 | mA | |
| Clock frequency | VOFFSET VBIAS VRESET VDDI - VDD VBIAS - VOFFSET VBIAS - VRESET VBIAS - VRESET INput voltage for Input voltage | Clock frequency for low speed interface LS_CLK | | 130 | MHz |
| Clock frequency | $f_{ m clock}$ | Clock frequency for high speed interface DCLK | | 620 | MHz |
| | T _{ARRAY} and | Temperature - operational ⁽⁸⁾ | - 20 | 90 | °C |
| Input pins Clock frequency | T _{WINDOW} | Temperature - non-operational ⁽⁸⁾ | - 40 | 90 | °C |
| Environmental | T _{DP} | | | 0.5 | °C |
| | T _{DELTA} | | | 30 | °C |

- (1) Operation outside the Absolute Maximum Ratings may cause permanent device damage. Absolute Maximum Ratings do not imply functional operation of the device at these or any other conditions beyond those listed under Recommended Operating Conditions. If outside the Recommended Operating Conditions but within the Absolute Maximum Ratings, the device may not be fully functional, and this may affect device reliability, functionality, performance, and shorten the device lifetime.
- (2) All voltage values are with respect to the ground terminals (VSS). The following power supplies are all required to operate the DMD: VDD, VDDI, VOFFSET, VBIAS, and VRESET. All VSS connections are also required.
- (3) VOFFSET supply transients must fall within specified voltages.
- (4) Exceeding the recommended allowable absolute voltage difference between VDDI and VDD may result in excessive current draw.
- (5) Exceeding the recommended allowable absolute voltage difference between VBIAS and VOFFSET may result in excessive current draw.
- (6) Exceeding the recommended allowable absolute voltage difference between VBIAS and VRESET may result in excessive current draw
- (7) This maximum input voltage rating applies when each input of a differential pair is at the same voltage potential. Sub-LVDS differential inputs must not exceed the specified limit or damage may result to the internal termination resistors.
- (8) The highest temperature of the active array (as calculated by the #7.6) or of any point along the Window Edge as defined in 图 7-1. The locations of thermal test points TP2, TP3, TP4, and TP5 in 图 7-1 are intended to measure the highest window edge temperature. If a particular application causes another point on the window edge to be at a higher temperature, that point should be used.
- (9) Temperature delta is the highest difference between the ceramic test point 1 (TP1) and anywhere on the window edge as shown in Section 7-1. The window test points TP2, TP3, TP4, and TP5 shown in Section 7-1 are intended to result in the worst case delta. If a particular application causes another point on the window edge to result in a larger delta temperature, that point should be used.

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6.2 Storage Conditions

applicable for the DMD as a component or non-operational in a system

| | | MIN | MAX | UNIT |
|---------------------|---|------|-----|--------|
| T _{DMD} | DMD storage temperature | - 40 | 85 | °C |
| T _{DP-AVG} | Average dew point temperature, (non-condensing) ⁽¹⁾ | | 24 | °C |
| T _{DP-ELR} | Elevated dew point temperature range, (non-condensing) ⁽²⁾ | 28 | 36 | °C |
| CT _{ELR} | Cumulative time in elevated dew point temperature range | | 6 | Months |

⁽¹⁾ The average over time (including storage and operating) that the device is not in the elevated dew point temperature range.

6.3 ESD Ratings

| | | | VALUE | UNIT |
|-------------|-------------------------|---|-------|------|
| $V_{(ESD)}$ | Electrostatic discharge | Human body model (HBM), per ANSI/ESDA/JEDEC JS-001 ⁽¹⁾ | ±2000 | V |

⁽¹⁾ JEDEC document JEP155 states that 500 V HBM allows safe manufacturing with a standard ESD control process.

6.4 Recommended Operating Conditions

Over operating free-air temperature range (unless otherwise noted)(1) (2) (3)

| | | MIN | NOM | MAX | UNIT |
|--|---|--------|------|--------------------------|------|
| SUPPLY VOLT | AGE RANGE ⁽⁴⁾ | | | | |
| V_{DD} | Supply voltage for LVCMOS core logic Supply voltage for LPSDR low-speed interface | 1.7 | 1.8 | 1.95 | V |
| V_{DDI} | Supply voltage for SubLVDS receivers | 1.7 | 1.8 | 1.95 | V |
| V _{OFFSET} | Supply voltage for HVCMOS and micromirror electrode ⁽⁵⁾ | 9.5 | 10 | 10.5 | V |
| V _{BIAS} | Supply voltage for mirror electrode | 17.5 | 18 | 18.5 | V |
| V _{RESET} | Supply voltage for micromirror electrode | - 14.5 | - 14 | - 13.5 | V |
| V _{DDI} - V _{DD} | Supply voltage delta (absolute value) ⁽⁶⁾ | | | 0.3 | V |
| V _{BIAS} - V _{OFFSET} | Supply voltage delta (absolute value) ⁽⁷⁾ | | | 10.5 | V |
| V _{BIAS} - V _{RESET} | Supply voltage delta (absolute value) ⁽⁸⁾ | | | 33 | V |
| CLOCK FREQ | UENCY | - | | | |
| f_{clock} | Clock frequency for low speed interface LS_CLK ⁽⁹⁾ | 108 | | 120 | MHz |
| f_{clock} | Clock frequency for high speed interface DCLK ⁽¹⁰⁾ | 300 | | 540 | MHz |
| | Duty cycle distortion DCLK | 44% | | 56% | |
| SUBLVDS INTI | ERFACE ⁽¹⁰⁾ | | - | | |
| V _{ID} | SubLVDS input differential voltage (absolute value) 图 6-9, 图 6-10 | 150 | 250 | 350 | mV |
| V _{CM} | Common mode voltage 图 6-9, 图 6-10 | 700 | 900 | 1100 | mV |
| V _{SUBLVDS} | SubLVDS voltage 图 6-9, 图 6-10 | 575 | - | 1225 | mV |
| Z _{LINE} | Line differential impedance (PWB/trace) | 90 | 100 | 110 | Ω |
| Z _{IN} | Internal differential termination resistance 图 6-11 | 80 | 100 | 120 | Ω |
| | 100-Ω differential PCB trace | 6.35 | | 152.4 | mm |
| ENVIRONMEN | TAL | - | | | |
| | Array Temperature - long-term operational ⁽¹¹⁾ (12) (13) (14) | 0 | | 40 to 70 ⁽¹³⁾ | |
| T _{ARRAY} | Array Temperature - short-term operational, 25 hr max ⁽¹²⁾ (15) | - 20 | | -10 | °C |
| | Array Temperature - short-term operational, 500 hr max ⁽¹²⁾ (15) | - 10 | | 0 | |
| | Array Temperature - short-term operational, 500 hr max ^{(12) (15)} | 70 | | 75 | |

⁽²⁾ Exposure to dew point temperatures in the elevated range during storage and operation should be limited to less than a total cumulative time of CT_{ELR}.



| | | MIN | NOM | MAX | UNIT |
|---------------------|--|-----|-----|------|--------------------|
| T _{DELTA} | Absolute Temperature difference between any point on the window edge and the ceramic test point TP1 (16) | | | 15 | °C |
| T _{WINDOW} | Window Temperature - operational ⁽¹¹⁾ (17) | | | 90 | °C |
| T _{DP-AVG} | Average dew point temperature (non-condensing) ⁽¹⁸⁾ | | | 24 | °C |
| T _{DP-ELR} | Elevated dew point temperature range (non-condensing) ⁽¹⁹⁾ | 28 | | 36 | °C |
| CT _{ELR} | Cumulative time in elevated dew point temperature range | | | 6 | Months |
| ILLUMINATION | | | | | |
| ILL _{UV} | Illumination power at wavelengths < 410 nm ⁽¹¹⁾ | | | 10 | mW/cm ² |
| ILL _{VIS} | Illumination power at wavelengths ≥ 410 nm and ≤ 800 nm ⁽²¹⁾ | | | 20.5 | W/cm ² |
| ILL _{IR} | Illumination power at wavelengths > 800 nm | | | 10 | mW/cm ² |
| ILL _{BLU} | Illumination power at wavelengths ≥ 410 nm and ≤ 475 nm ⁽²¹⁾ | | | 6.5 | W/cm ² |
| ILL _{BLU1} | Illumination power at wavelengths ≥ 410 nm and ≤ 445 nm ⁽²¹⁾ | | | 1.2 | W/cm2 |
| ILL ₀ | Illumination marginal ray angle ⁽²⁰⁾ | | | 55 | deg |

- (1) The following power supplies are all required to operate the DMD: VDD, VDDI, VOFFSET, VBIAS, and VRESET. All VSS connections are also required.
- (2) Recommended Operating Conditions are applicable after the DMD is installed in the final product.
- (3) The functional performance of the device specified in this data sheet is achieved when operating the device within the limits defined by the Recommended Operating Conditions. No level of performance is implied when operating the device above or below the Recommended Operating Conditions limits.
- (4) All voltage values are with respect to the ground pins (VSS).
- (5) VOFFSET supply transients must fall within specified max voltages.
- (6) To prevent excess current, the supply voltage delta |VDDI VDD| must be less than specified limit.
- (7) To prevent excess current, the supply voltage delta |VBIAS VOFFSET| must be less than specified limit.
- (8) To prevent excess current, the supply voltage delta |VBIAS VRESET| must be less than specified limit.
- (9) LS CLK must run as specified to ensure internal DMD timing for reset waveform commands.
- (10) Refer to the SubLVDS timing requirements in # 6.7.
- (11) Simultaneous exposure of the DMD to the maximum Recommended Operating Conditions for temperature and UV illumination will reduce device lifetime.
- (12) The array temperature cannot be measured directly and must be computed analytically from the temperature measured at test point 1 (TP1) shown in 🛭 7-1 and the Package Thermal Resistance using #7.6.
- (13) Per 🖺 6-1, the maximum operational array temperature should be derated based on the micromirror landed duty cycle that the DMD experiences in the end application. Refer to #7.8 for a definition of micromirror landed duty cycle.
- (14) Long-term is defined as the usable life of the device
- (15) Short-term is the total cumulative time over the useful life of the device.
- (16) Temperature delta is the highest difference between the ceramic test point 1 (TP1) and anywhere on the window edge shown in 🗵 7-1. The window test points TP2, TP3, TP4, and TP5 shown in 🖺 7-1 are intended to result in the worst case delta temperature. If a particular application causes another point on the window edge to result in a larger delta temperature, that point should be used.
- (17) Window temperature is the highest temperature on the window edge shown in

 7-1. The locations of thermal test points TP2, TP3, TP4, and TP5 in

 7-1 are intended to measure the highest window edge temperature. If a particular application causes another point on the window edge to be at a higher temperature, that point should be used.
- (18) The average over time (including storage and operating) that the device is not in the elevated dew point temperature range.
- (19) Exposure to dew point temperatures in the elevated range during storage and operation should be limited to less than a total cumulative time of CT_{ELR}.
- (20) The maximum marginal ray angle of the incoming illumination light at any point in the micromirror array, including Pond of Micromirrors (POM), should not exceed 55 degrees from the normal to the device array plane. The device window aperture has not necessarily been designed to allow incoming light at higher maximum angles to pass to the micromirrors, and the device performance has not been tested nor qualified at angles exceeding this. Illumination light exceeding this angle outside the micromirror array (including POM) will contribute to thermal limitations described in this document, and may negatively affect lifetime.
- (21) The maximum allowable optical power incident on the DMD is limited by the maximum optical power density for each wavelength range specified and the micromirror array temperature (T_{ARRAY}).

English Data Sheet: DLPS178



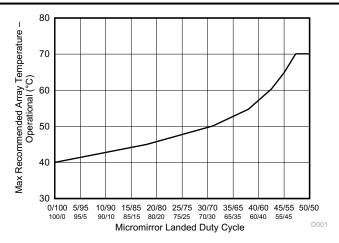


图 6-1. Max Recommended Array Temperature - Derating Curve



6.5 Thermal Information

| | | DLP4710LC | |
|--------------------|--|-----------|------|
| | THERMAL METRIC ⁽¹⁾ | FQL (LGA) | UNIT |
| | | 100 PINS | |
| Thermal resistance | Active area to test point 1 (TP1) ⁽¹⁾ | 1.1 | °C/W |

(1) The DMD is designed to conduct absorbed and dissipated heat to the back of the package. The cooling system must be capable of maintaining the package within the temperature range specified in the *Recommended Operating Conditions*. The total heat load on the DMD is largely driven by the incident light absorbed by the active area; although other contributions include light energy absorbed by the window aperture and electrical power dissipation of the array. Optical systems should be designed to minimize the light energy falling outside the window clear aperture since any additional thermal load in this area can significantly degrade the reliability of the device.

6.6 Electrical Characteristics

Over operating free-air temperature range (unless otherwise noted)(1)

| | PARAMETER | TEST CONDITIONS(2) | MIN | TYP | MAX | UNIT |
|--|---|---------------------------------------|-----------|-------|-----------|-------|
| CURRENT | | | | | | |
| Supply current: VDD ⁽³⁾ (4) | | V _{DD} = 1.95 V | | | 260 | m Λ |
| IDD | Supply current: VDD©/(4) | V _{DD} = 1.8 V | | 180 | | mA |
| 1 | Supply current: VDDI ⁽³⁾ (4) | V _{DDI} = 1.95 V | | | 62 | mA |
| I _{DDI} | Supply current. VDDIC-7 | V _{DDI} = = 1.8 V | | 40 | | IIIA |
| 1 | Supply current: VOFFSET ⁽⁵⁾ (6) | V _{OFFSET} = 10.5 V | | | 7.4 | mA |
| OFFSET | Supply current. VOFFSET(5/15) | V _{OFFSET} = 10 V | | 6.3 | | IIIA |
| | Supply current: VBIAS ⁽⁵⁾ (6) | VBIAS = 18.5 V | | | 1.1 | mA |
| I _{BIAS} | Supply current. VBIAS | VBIAS = 18 V | | 0.9 | | IIIA |
| | Complete Company (ADECET(6)) | VRESET = - 14.5 V | | | 5.4 | А |
| IRESET | Supply current: VRESET ⁽⁶⁾ | VRESET = - 14 V | | 4.4 | | mA |
| POWER ⁽⁷⁾ | | I | | L | I | |
| P _{DD} | Supply power dissipation: VDD ⁽³⁾ | VDD = 1.95 V | | | 507 | > |
| | | VDD = 1.8 V | | 324 | | mW |
| <u> </u> | Supply power dissipation: VDDI ⁽³⁾ (4) | VDDI = 1.95 V | | | 120.9 | \^/ |
| P_{DDI} | | VDD = 1.8 V | | 72 | | mW |
| П | Supply power dissipation: VOFFSET ⁽⁵⁾ (6) | VOFFSET = 10.5 V | | | 77.7 | mW |
| P _{OFFSET} | | VOFFSET = 10 V | | 63 | | IIIVV |
| D | Supply power dissipation: | VBIAS = 18.5 V | | | 20.35 | m\// |
| P _{BIAS} | VBIAS ⁽⁵⁾ (6) | VBIAS = 18 V | | 16.2 | | mW |
| D | Supply power dissipation: | VRESET = - 14.5 V | | | 78.3 | \^/ |
| P _{RESET} | VRESET ⁽⁶⁾ | VRESET = - 14 V | | 61.6 | | mW |
| P _{TOTAL} | Supply power dissipation: Total | | | 536.8 | 804.25 | mW |
| LPSDR INPL | JT ⁽⁸⁾ | | | - | | |
| V _{IH(DC)} | DC input high voltage ⁽⁹⁾ | | 0.7 × VDD | | VDD + 0.3 | V |
| V _{IL(DC)} | DC input low voltage ⁽⁹⁾ | | - 0.3 | | 0.3 × VDD | V |
| V _{IH(AC)} | AC input high voltage ⁽⁹⁾ | | 0.8 × VDD | | VDD + 0.3 | V |
| V _{IL(AC)} | AC input low voltage ⁽⁹⁾ | | - 0.3 | | 0.2 × VDD | V |
| ΔV_T | Hysteresis (V _{T+} - V _{T-}) | 图 6-12 | 0.1 × VDD | | 0.4 × VDD | V |
| I _{IL} | Low - level input current | VDD = 1.95 V; V _I = 0 V | - 100 | | | nA |
| I _{IH} | High - level input current | VDD = 1.95 V; V _I = 1.95 V | | | 100 | nA |
| LPSDR OUT | | | | | | |

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6.6 Electrical Characteristics (continued)

Over operating free-air temperature range (unless otherwise noted)⁽¹⁾

| | PARAMETER | TEST CONDITIONS(2) | MIN | TYP | MAX | UNIT |
|--------------------|---------------------------|--|-----------|-----|-----------|------|
| V _{OH} | DC output high voltage | I _{OH} = -2 mA | 0.8 × VDD | | | V |
| V _{OL} | DC output low voltage | I _{OL} = 2 mA | | | 0.2 × VDD | V |
| CAPACITANCE | | | | | | |
| | Input capacitance LPSDR | f = 1 MHz | | | 10 | pF |
| C _{IN} | Input capacitance SubLVDS | f = 1 MHz | | | 20 | pF |
| C _{OUT} | Output capacitance | f = 1 MHz | | | 10 | pF |
| C _{RESET} | Reset group capacitance | $f = 1 \text{ MHz}; (1080 \times 240)$ micromirrors | 400 | | 450 | pF |

- (1) Device electrical characteristics are over unless otherwise noted.
- (2) All voltage values are with respect to the ground pins (VSS).
- (3) To prevent excess current, the supply voltage delta |VDDI VDD| must be less than specified limit.
- 4) Supply power dissipation based on non compressed commands and data.
- (5) To prevent excess current, the supply voltage delta |VBIAS VOFFSET| must be less than specified limit.
- (6) Supply power dissipation based on 3 global resets in 200 μs.
- (7) The following power supplies are all required to operate the DMD: VDD, VDDI, VOFFSET, VBIAS, VRESET. All VSS connections are also required.
- (8) LPSDR specifications are for pins LS CLK and LS WDATA.
- (9) Low-speed interface is LPSDR and adheres to the Electrical Characteristics and AC/DC Operating Conditions table in JEDEC Standard No. 209B, Low-Power Double Data Rate (LPDDR) JESD209B.
- (10) LPSDR specification is for pin LS RDATA.

6.7 Timing Requirements

Device electrical characteristics are over unless otherwise noted.

| | | | MIN | NOM | MAX | UNIT |
|-----------------------|---|---|------|------|-----|------|
| LPSDR | | | | | | |
| t _r | Rise slew rate ⁽¹⁾ | (30% to 80%) × VDD, 图 6-3 | 1 | | 3 | V/ns |
| t_f | Fall slew rate ⁽¹⁾ | (70% to 20%) × VDD, 图 6-3 | 1 | | 3 | V/ns |
| t _r | Rise slew rate ⁽²⁾ | (20% to 80%) × VDD, 图 6-4 | 0.25 | | | V/ns |
| t_f | Fall slew rate ⁽²⁾ | (80% to 20%) × VDD, 图 6-4 | 0.25 | | | V/ns |
| t _c | Cycle time LS_CLK, | 图 6-2 | 7.7 | 8.3 | | ns |
| t _{W(H)} | Pulse duration LS_CLK high | 50% to 50% reference points, 图 6-2 | 3.1 | | | ns |
| t _{W(L)} | Pulse duration LS_CLK low | 50% to 50% reference points, 图 6-2 | 3.1 | | | ns |
| t _{su} | Setup time | LS_WDATA valid before LS_CLK ↑, 图 6-2 | 1.5 | | | ns |
| t h | Hold time | LS_WDATA valid after LS_CLK ↑, 图 6-2 | 1.5 | | | ns |
| t _{WINDOW} | Window time ⁽¹⁾ (3) | Setup time + Hold time, 图 6-2 | 3.0 | | | ns |
| t _{DERATING} | Window time derating ^{(1) (3)} | For each 0.25 V/ns reduction in slew rate below 1 V/ns, 图 6-6 | | 0.35 | | ns |
| SubLVDS | | | | | | |
| t _r | Rise slew rate | 20% to 80% reference points, 图 6-5 | 0.7 | 1 | | V/ns |
| t_f | Fall slew rate | 80% to 20% reference points, 图 6-5 | 0.7 | 1 | | V/ns |
| t _c | Cycle time DCLK, | 图 6-7 | 1.79 | 1.85 | | ns |
| t _{W(H)} | Pulse duration DCLK high | 50% to 50% reference points, 图 6-7 | 0.79 | | | ns |
| t _{W(L)} | Pulse duration DCLK low | 50% to 50% reference points, 图 6-7 | 0.79 | | | ns |
| t _{su} | Setup time | D(0:7) valid before DCLK ↑ or DCLK ↓, 图 6-7 | | | | |

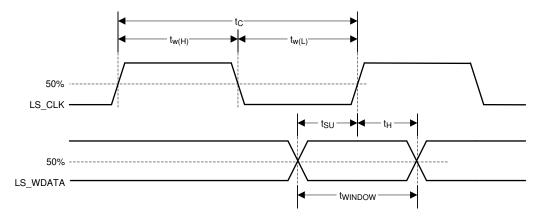


6.7 Timing Requirements (continued)

Device electrical characteristics are over unless otherwise noted.

| | | | MIN | NOM | MAX | UNIT |
|--------------------------------------|----------------------------------|--|-----|-----|------|------|
| t _h | Hold time | D(0:7) valid after DCLK ↑ or DCLK ↓ , 图 6-7 | | | | |
| t _{WINDOW} | Window time | Setup time + Hold time, 图 6-7, 图 6-8 | 3.0 | | | ns |
| t _{LVDS} - ENABLE+REFGEN | Power-up receiver ⁽⁴⁾ | | | | 2000 | ns |

- (1) Specification is for LS_CLK and LS_WDATA pins. Refer to LPSDR input rise slew rate and fall slew rate in 🛛 6-3.
- (2) Specification is for DMD_DEN_ARSTZ pin. Refer to LPSDR input rise and fall slew rate in 图 6-4.
- (3) Window time derating example: 0.5-V/ns slew rate increases the window time by 0.7 ns, from 3 to 3.7 ns.
- (4) Specification is for SubLVDS receiver time only and does not take into account commanding and latency after commanding.



Low-speed interface is LPSDR and adheres to the *Electrical Characteristics* and AC/DC Operating Conditions table in JEDEC Standard No. 209B, *Low Power Double Data Rate (LPDDR)* JESD209B.

图 6-2. LPSDR Switching Parameters

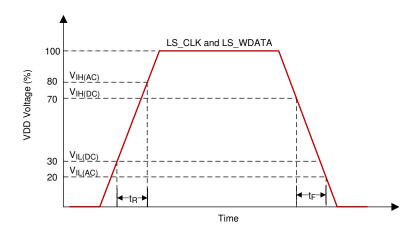


图 6-3. LPSDR Input Slew Rate

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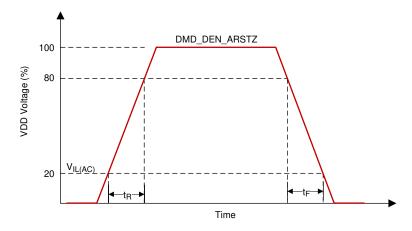


图 6-4. LPSDR Input Slew Rate

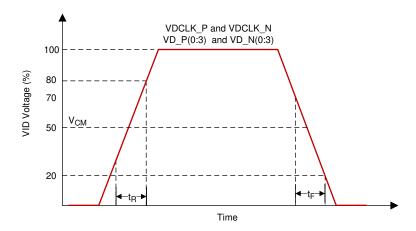
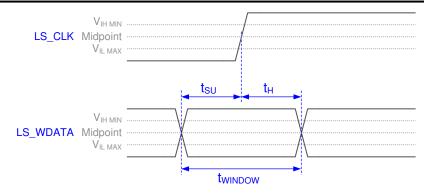


图 6-5. SubLVDS Input Rise and Fall Slew Rate





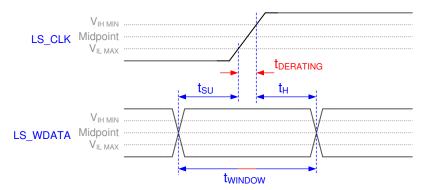


图 6-6. Window Time Derating Concept

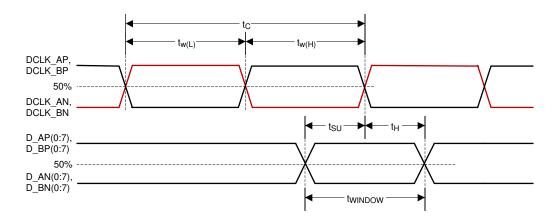
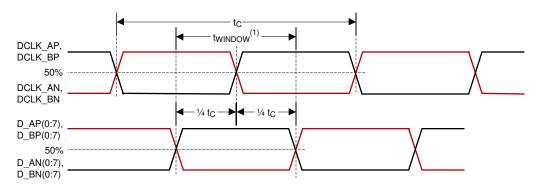


图 6-7. SubLVDS Switching Parameters

English Data Sheet: DLPS178





- (1) High-speed training scan window
- (2) Refer to High-Speed Interface for details

图 6-8. High-Speed Training Scan Window

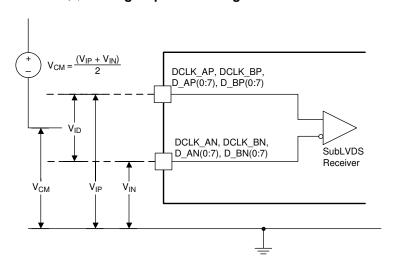


图 6-9. SubLVDS Voltage Parameters

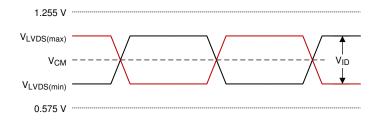


图 6-10. SubLVDS Waveform Parameters

 $V_{SubLVDS(max)} = V_{CM(max)} + \frac{1}{2} \times |V_{ID(max)}|$

 $V_{SubLVDS(min)} = V_{CM(min)} - \frac{1}{2} \times |V_{ID(max)}|$



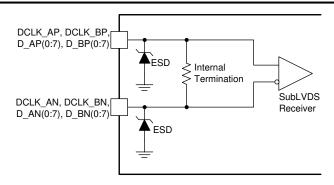


图 6-11. SubLVDS Equivalent Input Circuit

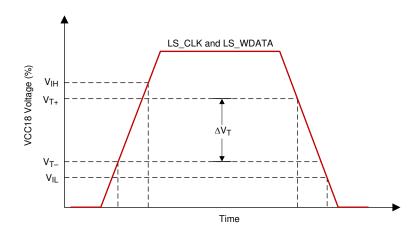


图 6-12. LPSDR Input Hysteresis

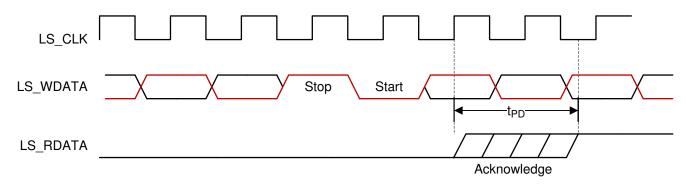
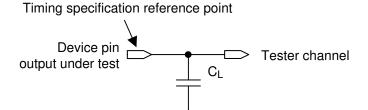


图 6-13. LPSDR Read Out

English Data Sheet: DLPS178





See *Timing* for more information.

图 6-14. Test Load Circuit for Output Propagation Measurement

6.8 Switching Characteristics

Over operating free-air temperature range (unless otherwise noted)(1).

| | PARAMETER | TEST CONDITIONS | MIN | TYP MAX | UNIT |
|-----------------|--|------------------------|-----|---------|------|
| t _{PD} | Output propagation, Clock to Q, rising edge of LS_CLK input to LS_RDATA output. 图 6-13 | C _L = 45 pF | | 15 | ns |
| | Slew rate, LS_RDATA | | 0.5 | | V/ns |
| | Output duty cycle distortion, LS_RDATA | | 40% | 60% | |

⁽¹⁾ Device electrical characteristics are over unless otherwise noted.

6.9 System Mounting Interface Loads

| PARAMETER | | MIN | NOM | MAX | UNIT |
|--|---|-----|-----|-----|------|
| Maximum system mounting interface load to be applied to the: | Thermal interface area (see 图 6-15) | | | 62 | N |
| | Clamping and electrical interface area (see 图 6-15) | | | 110 | N |



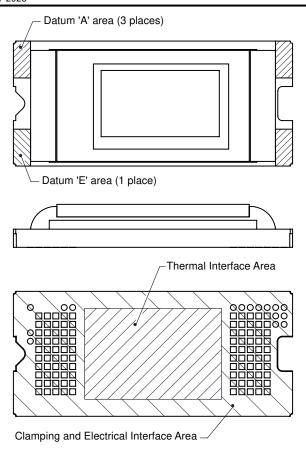


图 6-15. System Interface Loads

English Data Sheet: DLPS178



6.10 Physical Characteristics of the Micromirror Array

| | PARAMETER | | | UNIT |
|---|---------------------------------|--|--------|-------------------|
| | Number of active columns | See 图 6-16 | 1920 | micromirrors |
| | Number of active rows | See 🛚 6-16 | 1080 | micromirrors |
| ε | Micromirror (pixel) pitch | See 图 6-17 | 5.4 | μm |
| | Micromirror active array width | Micromirror pitch × number of active columns; see 图 6-16 | 10.368 | mm |
| | Micromirror active array height | Micromirror pitch × number of active rows; see | 5.832 | mm |
| | Micromirror active border | Pond of micromirror (POM) ⁽¹⁾ | 20 | micromirrors/side |

(1) The structure and qualities of the border around the active array includes a band of partially functional micromirrors called the POM. These micromirrors are structurally and/or electrically prevented from tilting toward the bright or ON state, but still require an electrical bias to tilt toward OFF.

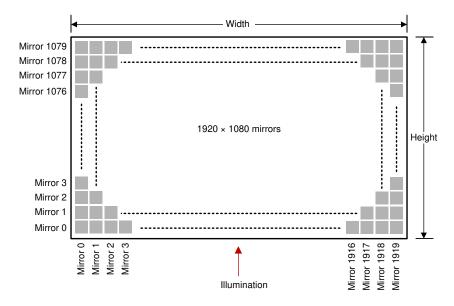


图 6-16. Micromirror Array Physical Characteristics

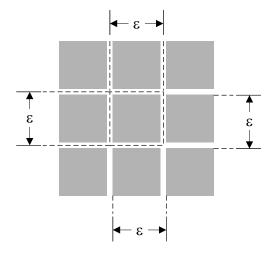


图 6-17. Mirror (Pixel) Pitch



6.11 Micromirror Array Optical Characteristics

| ı | PARAMETER | TEST CONDITIONS | MIN | NOM | MAX | UNIT |
|---|---|---------------------------------|-------|-----|-----|--------------|
| Micromirror tilt ang | le | DMD landed state ⁽¹⁾ | | 17 | | degree |
| Micromirror tilt ang | le tolerance ^{(2) (3) (4) (5)} | | - 1.4 | | 1.4 | degree |
| Mioromirror tilt diro | etion (6) (7) | Landed ON state | | 180 | | dograa |
| Micromirror tilt direction (6) (7) | | Landed OFF state | | 270 | | degree |
| Micromirror crossover time ⁽⁸⁾ | | Typical performance | | 1 | 3 | 116 |
| Micromirror switching time ⁽⁹⁾ | | Typical performance | 10 | | | μs |
| | Bright pixel(s) in active area | Gray 10 Screen (12) | | | 0 | |
| | Bright pixel(s) in the POM (13) | Gray 10 Screen (12) | | | 1 | |
| Image performance ⁽¹⁰⁾ | Dark pixel(s) in the active area (14) | White Screen | | | 4 | micromirrors |
| | Adjacent pixel(s) (15) | Any Screen | | | 0 | |
| | Unstable pixel(s) in active area (16) | Any Screen | | | 0 | |

- (1) Measured relative to the plane formed by the overall micromirror array.
- (2) Additional variation exists between the micromirror array and the package datums.
- (3) Represents the landed tilt angle variation relative to the nominal landed tilt angle.
- (4) Represents the variation that can occur between any two individual micromirrors, located on the same device or located on different devices.
- (5) For some applications, it is critical to account for the micromirror tilt angle variation in the overall system optical design. With some system optical designs, the micromirror tilt angle variation within a device may result in perceivable non-uniformities in the light field reflected from the micromirror array. With some system optical designs, the micromirror tilt angle variation between devices may result in colorimetry variations, system efficiency variations, or system contrast variations.
- (6) When the micromirror array is landed (not parked), the tilt direction of each individual micromirror is dictated by the binary contents of the CMOS memory cell associated with each individual micromirror. A binary value of 1 results in a micromirror landing in the ON state direction. A binary value of 0 results in a micromirror landing in the OFF state direction. See [8] 6-18.
- (7) Micromirror tilt direction is measured as in a typical polar coordinate system: Measuring counter-clockwise from a 0° reference which is aligned with the +X Cartesian axis.
- (8) The time required for a micromirror to nominally transition from one landed state to the opposite landed state.
- (9) The minimum time between successive transitions of a micromirror.
- (10) Conditions of Acceptance: All DMD image quality returns will be evaluated using the following projected image test conditions:

Test set degamma shall be linear

Test set brightness and contrast shall be set to nominal

The diagonal size of the projected image shall be a minimum of 20 inches

The projections screen shall be 1X gain

The projected image shall be inspected from a 38 inch minimum viewing distance

The image shall be in focus during all image quality tests

- (11) Bright pixel definition: A single pixel or mirror that is stuck in the ON position and is visibly brighter than the surrounding pixels
- (12) Gray 10 screen definition: All areas of the screen are colored with the following settings:

Red = 10/255

Green = 10/255

Blue = 10/255

- (13) POM definition: Rectangular border of off-state mirrors surrounding the active area
- (14) Dark pixel definition: A single pixel or mirror that is stuck in the OFF position and is visibly darker than the surrounding pixels
- (15) Adjacent pixel definition: Two or more stuck pixels sharing a common border or common point, also referred to as a cluster
- (16) Unstable pixel definition: A single pixel or mirror that does not operate in sequence with parameters loaded into memory. The unstable pixel appears to be flickering asynchronously with the image

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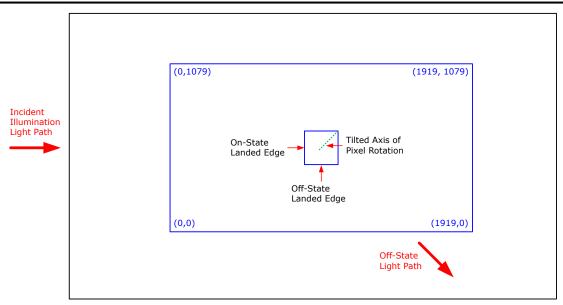


图 6-18. Landed Pixel Orientation and Tilt



6.12 Window Characteristics

| PARA | PARAMETER ⁽¹⁾ | | | MAX | UNIT |
|---|---|-----|--------|---------|------|
| Window material designation | Window material designation | | | | |
| Window refractive index | at wavelength 546.1 nm | | 1.5119 | | |
| Window aperture ⁽²⁾ | | | | See (2) | |
| Illumination overfill ⁽³⁾ | | | | See (3) | |
| Window transmittance, single-pass through both surfaces and glass | Minimum within the wavelength range 420 to 680 nm. Applies to all angles 0° to 30° AOI. | 97% | | | |
| Window Transmittance, single-pass through both surfaces and glass | Average over the wavelength range 420 to 680 nm. Applies to all angles 30° to 45° AOI. | 97% | | | |

- (1) See Optical Interface and System Image Quality Considerations for more information.
- (2) See the package mechanical characteristics for details regarding the size and location of the window aperture.
- (3) The active area of the DLP4710LC device is surrounded by an aperture on the inside of the DMD window surface that masks structures of the DMD device assembly from normal view. The aperture is sized to anticipate several optical conditions. Overfill light illuminating the area outside the active array can scatter and create adverse effects to the performance of an end application using the DMD. The illumination optical system should be designed to limit light flux incident outside the active array to less than 10% of the average flux level in the active area. Depending on the particular system's optical architecture and assembly tolerances, the amount of overfill light on the outside of the active array may cause system performance degradation.

6.13 Chipset Component Usage Specification

The DLP4710LC is a component of one or more TI DLP® chipsets. Reliable function and operation of the DLP4710LC requires that it be used in conjunction with the other components of the applicable DLP chipset, including those components that contain or implement TI DMD control technology. TI DMD control technology is the TI technology and devices for operating or controlling a DLP DMD.

备注

TI assumes no responsibility for image quality artifacts or DMD failures caused by optical system operating conditions exceeding limits described previously.

6.14 Software Requirements

CAUTION

The DLP4710LC DMD has mandatory software requirements. Refer to *Software Requirements for TI DLP®Pico™ TRP Digital Micromirror Devices* application report for additional information. Failure to use the specified software will result in failure at power up.

Product Folder Links: DLP4710LC

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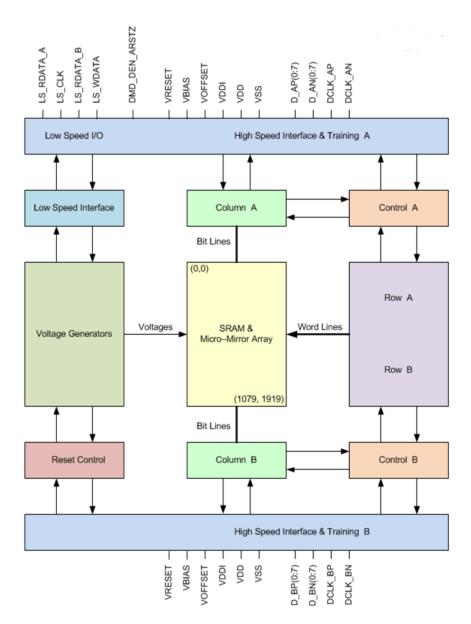
7 Detailed Description

7.1 Overview

The DLP4710LC device is a 0.47 inch diagonal spatial light modulator of aluminum micromirrors. Pixel array size is 1920 columns by 1080 rows in a square grid pixel arrangement. The electrical interface is Sub Low Voltage Differential Signaling (SubLVDS) data.

DLP4710LC device is part of the chipset comprising the DLP4710LC DMD, DLPC3479 controller, and DLPA3000 or DLPA3005 PMIC/LED driver. To ensure reliable operation, the DLP4710LC DMD must always be used with either the DLPC3479 controller and the DLPA3000 or DLPA3005 PMIC/LED drivers.

7.2 Functional Block Diagram



Simplified for clarity.

7.3 Feature Description

7.3.1 Power Interface

The power management IC, DLPA3000/DLPA3005, contains three regulated DC supplies for the DMD reset circuitry: VBIAS, VRESET and VOFFSET, as well as the 2 regulated DC supplies for the DLPC3479 controller.

7.3.2 Low-Speed Interface

The Low Speed Interface handles instructions that configure the DMD and control reset operation. LS_CLK is the low - speed clock, and LS_WDATA is the low speed data input.

7.3.3 High-Speed Interface

The purpose of the high-speed interface is to transfer pixel data rapidly and efficiently, making use of high speed DDR transfer and compression techniques to save power and time. The high-speed interface is composed of differential SubLVDS receivers for inputs, with a dedicated clock.

7.3.4 Timing

The data sheet provides timing test results at the device pin. For output timing analysis, the tester pin electronics and its transmission line effects must be considered. Test Load Circuit for Output Propagation Measurement shows an equivalent test load circuit for the output under test. Timing reference loads are not intended as a precise representation of any particular system environment or depiction of the actual load presented by a production test. TI recommends that system designers use IBIS or other simulation tools to correlate the timing reference load to a system environment. The load capacitance value stated is intended for characterization and measurement of AC timing signals only. This load capacitance value does not indicate the maximum load the device is capable of driving.

7.4 Device Functional Modes

DMD functional modes are controlled by the DLPC3479 controller. See the DLPC3479 controller data sheet or contact a TI applications engineer.

7.5 Optical Interface and System Image Quality Considerations

备注

TI assumes no responsibility for image quality artifacts or DMD failures caused by optical system operating conditions exceeding limits described previously.

7.5.1 Optical Interface and System Image Quality

TI assumes no responsibility for end-equipment optical performance. Achieving the desired end-equipment optical performance involves making trade-offs between numerous component and system design parameters. Optimizing system optical performance and image quality strongly relate to optical system design parameter trades. Although it is not possible to anticipate every conceivable application, projector image quality and optical performance is contingent on compliance to the optical system operating conditions described in the following sections.

7.5.1.1 Numerical Aperture and Stray Light Control

The angle defined by the numerical aperture of the illumination and projection optics at the DMD optical area is typically the same. Ensure this angle does not exceed the nominal device micromirror tilt angle unless appropriate apertures are added in the illumination or projection pupils to block out flat-state and stray light from the projection lens. The micromirror tilt angle defines DMD capability to separate the "ON" optical path from any other light path, including undesirable flat – state specular reflections from the DMD window, DMD border structures, or other system surfaces near the DMD such as prism or lens surfaces. If the numerical aperture exceeds the micromirror tilt angle, or if the projection numerical aperture angle is more than two degrees larger than the illumination numerical aperture angle (and vice versa), contrast degradation and objectionable artifacts in the display border and/or active area may occur.

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7.5.1.2 Pupil Match

The optical and image quality specifications assume that the exit pupil of the illumination optics is nominally centered within 2° of the entrance pupil of the projection optics. Misalignment of pupils can create objectionable artifacts in the display border and/or active area. These artifacts may require additional system apertures to control, especially if the numerical aperture of the system exceeds the pixel tilt angle.

7.5.1.3 Illumination Overfill

The active area of the device is surrounded by an aperture on the inside DMD window surface that masks structures of the DMD chip assembly from normal view, and is sized to anticipate several optical operating conditions. Overfill light illuminating the window aperture can create artifacts from the edge of the window aperture opening and other surface anomalies that may be visible on the screen. Be sure to design an illumination optical system that limits light flux incident anywhere on the window aperture from exceeding approximately 10% of the average flux level in the active area. Depending on the particular optical architecture, overfill light may require further reduction below the suggested 10% level in order to be acceptable.

7.6 Micromirror Array Temperature Calculation

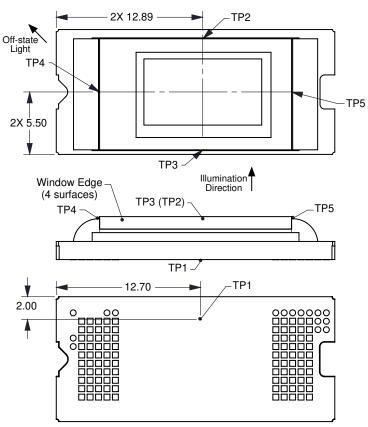


图 7-1. DMD Thermal Test Points

Product Folder Links: DLP4710LC

 $T_{ARRAY} = T_{CERAMIC} + (Q_{ARRAY} \times R_{ARRAY-TO-CERAMIC})$

 $Q_{ARRAY} = Q_{ELECTRICAL} + Q_{ILLUMINATION}$

where



- T_{ARRAY} = Computed array temperature (°C)
- T_{CFRAMIC} = Measured ceramic temperature (°C) (TP1 location)
- R_{ARRAY-TO-CERAMIC} = Thermal resistance of package specified in #6.5 from array to ceramic TP1 (°C/Watt)
- Q_{ARRAY} = Total DMD power on the array (W) (electrical + absorbed)
- Q_{ELECTRICAL} = Nominal electrical power (W)
- Q_{INCIDENT} = Incident illumination optical power (W)
- Q_{ILLUMINATION} = (DMD average thermal absorptivity × Q_{INCIDENT}) (W)
- DMD average thermal absorptivity = 0.4

The electrical power dissipation of the DMD is variable and depends on the voltages, data rates and operating frequencies. A nominal electrical power dissipation to use when calculating array temperature is 0.25 Watts. The absorbed power from the illumination source is variable and depends on the operating state of the micromirrors and the intensity of the light source. The equations shown above are valid for a single chip or multichip DMD system. It assumes an illumination distribution of 83.7% on the active array, and 16.3% on the array border.

The sample calculation for a typical projection application is as follows:

```
Q_{\mathsf{INCIDENT}} = 9.4 \; \mathsf{W} \; (\mathsf{measured}) T_{\mathsf{CERAMIC}} = 55.0 ^{\circ} \mathsf{C} \; (\mathsf{measured}) Q_{\mathsf{ELECTRICAL}} = 0.25 \; \mathsf{W} Q_{\mathsf{ARRAY}} = 0.25 \; \mathsf{W} + (0.40 \times 9.4 \; \mathsf{W}) = 4.01 \; \mathsf{W} T_{\mathsf{ARRAY}} = 55.0 ^{\circ} \mathsf{C} + (4.01 \; \mathsf{W} \times 1.1 ^{\circ} \mathsf{C/W}) = 59.4 ^{\circ} \mathsf{C}
```

7.7 Micromirror Power Density Calculation

The calculation of the optical power density of the illumination on the DMD in the different wavelength bands uses the total measured optical power on the DMD, percent illumination overfill, area of the active array, and ratio of the spectrum in the wavelength band of interest to the total spectral optical power.

- ILL_{UV} = [OP_{UV-RATIO} × Q_{INCIDENT}] × 1000 ÷ A_{ILL} (mW/cm²)
- ILL_{VIS} = [OP_{VIS-RATIO} × Q_{INCIDENT}] ÷ A_{ILL} (W/cm²)
- ILL_{IR} = [OP_{IR-RATIO} × Q_{INCIDENT}] × 1000 ÷ A_{ILL} (mW/cm²)
- ILL_{BLU} = [OP_{BLU-RATIO} × Q_{INCIDENT}] ÷ A_{ILL} (W/cm²)
- ILL_{BLU1} = [OP_{BLU1-RATIO} × Q_{INCIDENT}] ÷ A_{ILL} (W/cm²)
- $A_{ILL} = A_{ARRAY} \div (1 OV_{ILL}) (cm^2)$

where:

- ILL_{UV} = UV illumination power density on the DMD (mW/cm²)
- ILL_{VIS} = VIS illumination power density on the DMD (W/cm²)
- ILL_{IR} = IR illumination power density on the DMD (mW/cm²)
- ILL_{BLU} = BLU illumination power density on the DMD (W/cm²)



- ILL_{BLU1} = BLU1 illumination power density on the DMD (W/cm²)
- A_{II I} = illumination area on the DMD (cm²)
- Q_{INCIDENT} = total incident optical power on DMD (W) (measured)
- A_{ARRAY} = area of the array (cm²) (data sheet)
- OV_{III} = percent of total illumination on the DMD outside the array (%) (optical model)
- OP_{UV-RATIO} = ratio of the optical power for wavelengths <410 nm to the total optical power in the illumination spectrum (spectral measurement)
- OP_{VIS-RATIO} = ratio of the optical power for wavelengths ≥410 and ≤800 nm to the total optical power in the illumination spectrum (spectral measurement)
- OP_{IR-RATIO} = ratio of the optical power for wavelengths >800 nm to the total optical power in the illumination spectrum (spectral measurement)
- OP_{BLU-RATIO} = ratio of the optical power for wavelengths ≥410 and ≤475 nm to the total optical power in the illumination spectrum (spectral measurement)
- OP_{BLU1-RATIO} = ratio of the optical power for wavelengths ≥410 and ≤445 nm to the total optical power in the illumination spectrum (spectral measurement)

The illumination area varies and depends on the illumination overfill. The total illumination area on the DMD is the array area and overfill area around the array. The optical model is used to determine the percent of the total illumination on the DMD that is outside the array (OV_{ILL}) and the percent of the total illumination that is on the active array. From these values the illumination area (A_{ILL}) is calculated. The illumination is assumed to be uniform across the entire array.

From the measured illumination spectrum, the ratio of the optical power in the wavelength bands of interest to the total optical power is calculated.

Sample calculation:

```
\begin{aligned} &Q_{\text{INCIDENT}} = 9.40 \text{ W (measured)} \\ &A_{\text{ARRAY}} = (1.0368 \times 0.5832) = 0.6047 \text{ cm}^2 \text{ (data sheet)} \\ &OV_{\text{ILL}} = 16.3\% \text{ (optical model)} \\ &OP_{\text{UV-RATIO}} = 0.00021 \text{ (spectral measurement)} \\ &OP_{\text{VIS-RATIO}} = 0.99977 \text{ (spectral measurement)} \\ &OP_{\text{IR-RATIO}} = 0.00002 \text{ (spectral measurement)} \\ &OP_{\text{BLU-RATIO}} = 0.28100 \text{ (spectral measurement)} \\ &OP_{\text{BLU-RATIO}} = 0.03200 \text{ (spectral measurement)} \\ &OP_{\text{BLU1-RATIO}} = 0.03200 \text{ (spectral measurement)} \\ &A_{\text{ILL}} = 0.6047 \div (1 - 0.163) = 0.7224 \text{ cm}^2 \\ &ILL_{\text{UV}} = [0.00021 \times 9.40\text{W}] \times 1000 \div 0.7224 \text{ cm}^2 = 2.732 \text{ mW/cm}^2 \\ &ILL_{\text{VIS}} = [0.99977 \times 9.40\text{W}] \div 0.7224 \text{ cm}^2 = 13.01 \text{ W/cm}^2 \\ &ILL_{\text{IR}} = [0.00002 \times 9.40\text{W}] \times 1000 \div 0.7224 \text{ cm}^2 = 0.260 \text{ mW/cm}^2 \end{aligned}
```



 $ILL_{BLU} = [0.28100 \times 9.40W] \div 0.7224 \text{ cm}^2 = 3.66 \text{ W/cm}^2$ $ILL_{BLU1} = [0.03200 \times 9.40W] \div 0.7224 \text{ cm}^2 = 0.42 \text{ W/cm}^2$

7.8 Micromirror Landed-On/Landed-Off Duty Cycle

7.8.1 Definition of Micromirror Landed-On and Landed-Off Duty Cycle

The micromirror landed-on/landed-off duty cycle (landed duty cycle) denotes the amount of time (as a percentage) that an individual micromirror is landed in the ON state versus the amount of time the same micromirror is landed in the OFF state.

As an example, a landed duty cycle of 75/25 indicates that the referenced pixel is in the ON state 75% of the time (and in the OFF state 25% of the time), whereas 25/75 indicates that the pixel is in the OFF state 75% of the time. Likewise, 50/50 indicates that the pixel is ON 50% of the time and OFF 50% of the time.

When assessing landed duty cycle, the time spent switching from the current state to the opposite state is considered negligible and is thus ignored.

Because a micromirror can only be landed in one state or the other (ON or OFF), the two numbers (percentages) nominally add to 100.In practice, image processing algorithms in the DLP chipset can result a total of less that 100.

7.8.2 Landed Duty Cycle and Useful Life of the DMD

Knowing the long-term average landed duty cycle (of the end product or application) is important because subjecting all (or a portion) of the DMD's micromirror array (also called the active array) to an asymmetric landed duty cycle for a prolonged period of time can reduce the DMD's usable life.

It is the symmetry or asymmetry of the landed duty cycle that is relevant. The symmetry of the landed duty cycle is determined by how close the two numbers (percentages) are to being equal. For example, a landed duty cycle of 50/50 is perfectly symmetrical whereas a landed duty cycle of 100/0 or 0/100 is perfectly asymmetrical.

7.8.3 Landed Duty Cycle and Operational DMD Temperature

Operational DMD temperature and landed duty cycle interact to affect the usable life of the DMD. This interaction can be used to reduce the impact that an asymmetrical landed duty cycle has on the useable life of the DMD. 🖺 6-1 describes this relationship. The importance of this curve is that:

- All points along this curve represent the same usable life.
- All points above this curve represent lower usable life (and the further away from the curve, the lower the usable life).
- All points below this curve represent higher usable life (and the further away from the curve, the higher the usable life).

In practice, this curve specifies the maximum operating DMD temperature that the DMD should be operated at for a give long-term average landed duty cycle.

7.8.4 Estimating the Long-Term Average Landed Duty Cycle of a Product or Application

During a given period of time, the landed duty cycle of a given pixel depends on the image content being displayed by that pixel.

In the simplest case for example, when the system displays pure-white on a given pixel for a given time period, that pixel operates very close to a 100/0 landed duty cycle during that time period. Likewise, when the system displays pure-black, the pixel operates very close to a 0/100 landed duty cycle.

Between the two extremes (ignoring for the moment color and any image processing that may be applied to an incoming image), the landed duty cycle tracks one-to-one with the gray scale value, as shown in 表 7-1.

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English Data Sheet: DLPS178

| 表 7-1. Grayscale Value | |
|------------------------|--|
| and Landed Duty Cycle | |

| Grayscale Value | Nominal Landed Duty Cycle |
|--------------------|---------------------------------|
| 0% | 0/100 |
| 10% | 10/90 |
| 20% | 20/80 |
| 30% | 30/70 |
| 40% | 40/60 |
| 50% | 50/50 |
| 60% | 60/40 |
| 70% | 70/30 |
| 80% | 80/20 |
| 90% | 90/10 |
| 100% | 100/0 |

To account for color rendition (and continuing to ignore image processing for this example) requires knowing both the color intensity (from 0% to 100%) for each constituent primary color (red, green, and/or blue) for the given pixel as well as the color cycle time for each primary color, where *color cycle time* describes the total percentage of the frame time that a given primary must be displayed in order to achieve the desired white point.

During a given period of time, the nominal landed duty cycle of a given pixel can be calculated as shown in 方程 式 1:

Landed Duty Cycle = (Red_Cycle_% × Red_Scale_Value) + (Green_Cycle_% × Green_Scale_Value) + (Blue_Cycle_% (1) × Blue_Scale_Value)

where

- Red_Cycle_% represents the percentage of the frame time that red displays to achieve the desired white
 point
- Green_Cycle_% represents the percentage of the frame time that green displays to achieve the desired white point
- Blue_Cycle_% represents the percentage of the frame time that blue displays to achieve the desired white point

For example, assume that the ratio of red, green and blue color cycle times are as listed in $\frac{1}{8}$ 7-2 (in order to achieve the desired white point) then the resulting nominal landed duty cycle for various combinations of red, green, blue color intensities are as shown in $\frac{1}{8}$ 7-3.

表 7-2. Example Landed Duty Cycle for Full-Color Pixels

| Red Cycle | Green Cycle | Blue Cycle | | | | |
|------------|-------------|------------|--|--|--|--|
| Percentage | Percentage | Percentage | | | | |
| 50% | 20% | 30% | | | | |

表 7-3. Color Intensity Combinations

| ser or color intendity combinations | | | | | | | | | | | |
|-------------------------------------|----------------------|---------------------|---------------------------------|--|--|--|--|--|--|--|--|
| Red Scale Value | Green Scale Value | Blue Scale Value | Nominal Landed Duty Cycle | | | | | | | | |
| 0% | 0% | 0% | 0/100 | | | | | | | | |
| 100% | 0% | 0% | 50/50 | | | | | | | | |
| 0% | 100% | 0% | 20/80 | | | | | | | | |

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表 7-3. Color Intensity Combinations (continued)

| Red Scale Value | Green Scale Value | Blue Scale Value | Nominal Landed Duty Cycle | | |
|--------------------|----------------------|---------------------|---------------------------------|--|--|
| 0% | 0% | 100% | 30/70 | | |
| 12% | 0% | 0% | 6/94 | | |
| 0% | 35% | 0% | 7/93 | | |
| 0% | 0% | 60% | 18/82 | | |
| 100% | 100% | 0% | 70/30 | | |
| 0% | 100% | 100% | 50/50 | | |
| 100% | 0% | 100% | 80/20 | | |
| 12% | 35% | 0% | 13/87 | | |
| 0% | 35% | 60% | 25/75 | | |
| 12% | 0% | 60% | 24/76 | | |
| 100% | 100% | 100% | 100/0 | | |

The last factor to consider when estimating the landed duty cycle is any applied image processing. In the DLPC34xx controller family, the two functions which influence the actual landed duty cycle are Gamma and IntelliBright™, and bitplane sequencing rules.

Gamma is a power function of the form $Output_Level = A \times Input_Level^{Gamma}$, where A is a scaling factor that is typically set to 1.

In the DLPC34xx controller family, gamma is applied to the incoming image data on a pixel-by-pixel basis. A typical gamma factor is 2.2, which transforms the incoming data as shown in $\boxed{8}$ 7-2.



图 7-2. Example of Gamma = 2.2

As shown in $\boxed{8}$ 7-2, when the gray scale value of a given input pixel is 40% (before gamma is applied), then gray scale value is 13% after gamma is applied. Because gamma has a direct impact on the displayed gray scale level of a pixel, it also has a direct impact on the landed duty cycle of a pixel.

The IntelliBright algorithms content adaptive illumination control (CAIC) and local area brightness boost (LABB) also apply transform functions on the gray scale level of each pixel.

But while amount of gamma applied to every pixel (of every frame) is constant (the exponent, gamma, is constant), CAIC and LABB are both adaptive functions that can apply a different amounts of either boost or compression to every pixel of every frame.

Product Folder Links: DLP4710LC

Be sure to account for any image processing which occurs before the controller.

8 Application and Implementation

备注

以下应用部分中的信息不属于 TI 器件规格的范围, TI 不担保其准确性和完整性。TI 的客户应负责确定器件是否适用于其应用。客户应验证并测试其设计,以确保系统功能。

8.1 Application Information

The DMDs are spatial light modulators which reflect incoming light from an illumination source to one of two directions, with the primary direction being into a projection or collection optic. Each application is derived primarily from the optical architecture of the system and the format of the data coming into the dual DLPC3479 controllers. The new high tilt pixel in the bottom-illuminated DMD increases brightness performance and enables a smaller system footprint for thickness constrained applications. Applications of interest include

- 3D depth capture: 3D camera, 3D reconstruction, dental scanner
- 3D machine vision: robotics, metrology, automated in-line inspection (AOI)
- 3D biometrics: facial and finger print recognition
- · Integrated Display and 3D Depth Capture: Projection mapping, smart lighting, Glass-free AR Projection
- · Light Exposure: Programmable spatial and temporal light exposure

DMD power-up and power-down sequencing is strictly controlled by the DLPA3000/DLPA3005. Refer to *Power Supply Recommendations* for power-up and power-down specifications. To ensure reliable operation, the DLP4710LC DMD must always be used with two DLPC3479 controllers and a DLPA3000 or DLPA3005 PMIC/LED driver.

8.2 Typical Application

A pattern-projector that can be used for high resolution 3D scan and display in 3D Scanners, Dental Scanners, Metrology, projection mapping, etc., is a common application when using a DLP4710LC DMD and two DLPC3479 devices. The two DLPC3479 devices in the pico-projector receive images from a multimedia front end within the product as shown in 8-1.

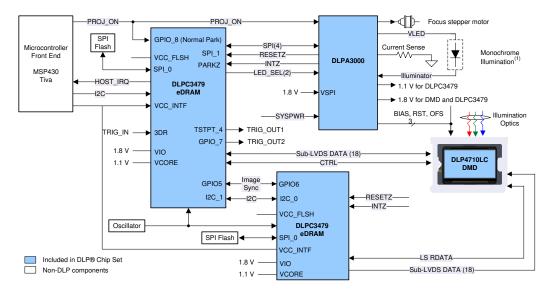


图 8-1. Typical Application Diagram

8.2.1 Design Requirements

A high-accuracy, 3D depth capture product is created by using a DLP chipset comprised of DLP4710LC DMD, 2xDLPC3479 controller and DLPA3000 PMIC/LED drive. The DLPC3479 simplifies the pattern generation, the

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DLPA3000 provides the needed analog functions and DMD displays the required patterns for accurate 3D depth capture. In addition to the three DLP devices in the chipset, other components may be required to complete the application. Minimally, a flash component is required to store patterns, the software, and the firmware in order to control the DLPC3479 controller. DLPC3479 controller supports any illumination source including IR light source (LEDs or VCSEL), UV light source or visible light source (Red, Green or Blue LEDs or lasers).

To send commands from the host processor to the DLPC3479, connect the two via I²C. The only power supplies needed for the DLP4710LC chipset is the input power (SYSPWR). All other needed supplies are being provided by the DLPA3000 or DLPA3005 PMIC for this chipset. A single signal (PROJ_ON) controls the entire DLP system power. When PROJ_ON is high, the DLP system turns on and when PROJ_ON is low, the DLPC3479 turns off and draws only a few microamperes of current on SYSPWR.

The TSTPT_2 pin on the master controller outputs a 25ns pulse width that should be connected to the 3DR (input) pin of the slave controller. In case VCC_INTF is not set to 1.8V, a voltage translator is required. The propagation delay between the rising edge of TSTPT_2 pin on the master controller and the VIH of 3DR (input) pin on slave controller is recommended to be under 10ns.

8.2.2 Detailed Design Procedure

For connecting the two DLPC3479 controllers, the DLPA3000/DLPA3005, and the DLP4710LC DMD, see the reference design schematic. When a circuit board layout is created from this schematic a very small circuit board is possible. An example small board layout is included in the reference design data base. Layout guidelines should be followed to achieve a reliable projector.

The optical engine that has the LED packages and the DMD mounted to it is typically supplied by an optical OEM who specializes in designing optics for DLP projectors.

8.2.3 Application Curve

As the LED currents that are driven time-sequentially through the red, green, and blue LEDs are increased, the brightness of the projector increases. This increase is somewhat non-linear, and the curve for typical white screen lumens changes with LED currents is as shown in 88-2. For the LED currents shown, it's assumed that the same current amplitude is applied to the red, green, and blue LEDs.

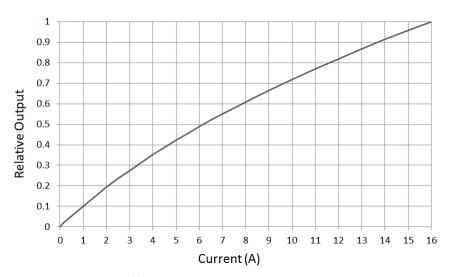


图 8-2. Luminance vs Current

Product Folder Links: DLP4710LC

9 Power Supply Recommendations

The following power supplies are all required to operate the DMD:

- VSS
- VBIAS
- VDD
- VDDI
- VOFFSET
- VRESET

The DLPAxxxx device strictly controls the DMD power-up and power-down sequences.

CAUTION

Failure to follow these power supply sequencing requirements may adversley affect device reliability. See the DMD power supply sequencing requirements in

9-1.

VBIAS, VDD, VDDI, VOFFSET, and VRESET power supplies must be coordinated during power-up and power-down operations. Failure to meet any of these requirements results in a significant reduction in the DMD reliability and lifetime. Common ground VSS must also be connected.

9.1 DMD Power Supply Power-Up Procedure

- During the power-up sequence, VDD and VDDI must always start and settle before VOFFSET, VBIAS, and VRESET voltages are applied to the DMD.
- During the power-up sequence, it is a strict requirement that the voltage difference between VBIAS and VOFFSET must be within the specified limit shown in *Recommended Operating Conditions*. Refer to 表 9-1 for the power-up sequence, delay requirements.
- During the power-up sequence, there is no requirement for the relative timing of VRESET with respect to VBIAS and VOFFSET.
- Power supply slew rates during the power-up sequence are flexible, provided that the transient voltage levels follow the requirements specified in *Absolute Maximum Ratings*, in *Recommended Operating Conditions*, and in Power Supply Sequencing Requirements.
- During the power-up sequence, LPSDR input pins must not be driven high until after VDD/VDDI have settled at operating voltages listed in *Recommended Operating Conditions*.

9.2 DMD Power Supply Power-Down Procedure

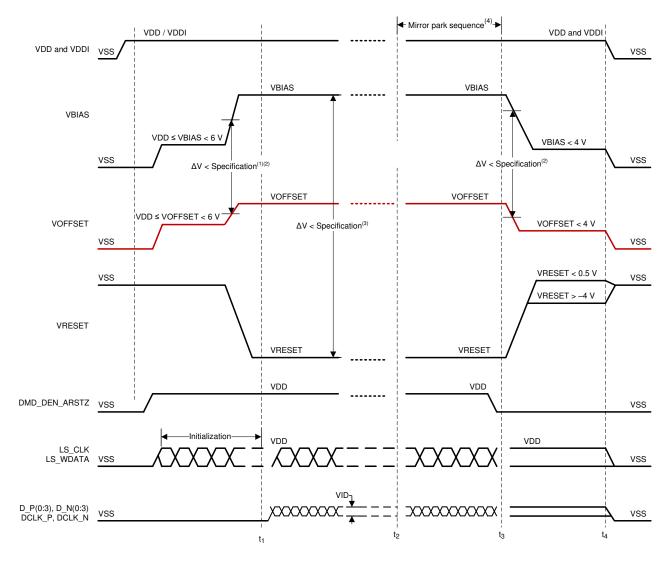
- The power-down sequence is the reverse order of the previous power-up sequence. During the power-down sequence, VDD and VDDI must be supplied until after VBIAS, VRESET, and VOFFSET are discharged to within 4 V of ground.
- During the power-down sequence, it is a strict requirement that the voltage difference between VBIAS and VOFFSET must be within the specified limit shown in *Recommended Operating Conditions*.
- During the power-down sequence, there is no requirement for the relative timing of VRESET with respect to VBIAS and VOFFSET.
- Power supply slew rates during the power-down sequence, are flexible, provided that the transient voltage levels follow the requirements specified in *Absolute Maximum Ratings*, in *Recommended Operating Conditions*, and in Power Supply Sequencing Requirements.

Product Folder Links: DLP4710LC

 During the power-down sequence, LPSDR input pins must be less than VDD/VDDI specified in Recommended Operating Conditions.



9.3 Power Supply Sequencing Requirements



DLP display controller software controls start of DMD operation

Mirror park sequence starts

Mirror park sequence ends. DLP PMIC/LED driver disables VBIAS, VOFFSET, and VRESET.

Power off.

Refer to 表 9-1 and 图 9-2 for critical power-up sequence delay requirements.

When system power is interrupted, the ASIC driver initiates hardware the power-down sequence, that disables VBIAS, VRESET and VOFFSET after the micromirror park sequence is complete. Software the power-down sequence, disables VBIAS, VRESET, and VOFFSET after the micromirror park sequence through software control.

To prevent excess current, the supply voltage delta |VBIAS - VRESET| must be less than specified limit shown in *Recommended Operating Conditions*.

Drawing is not to scale and details are omitted for clarity.

图 9-1. Power Supply Sequencing Requirements

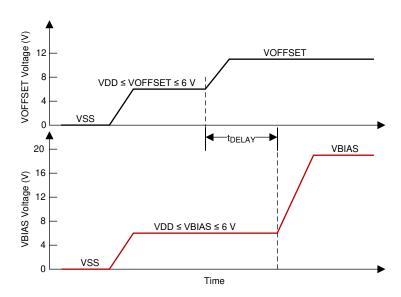
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表 9-1. Power-Up Sequence Delay Requirement

| | PARAMETER | MIN | MAX | UNIT |
|--------------------|---|-----|-----|------|
| t _{DELAY} | Delay requirement from VOFFSET power up to VBIAS power up | 2 | | ms |
| VOFFSE T | Supply voltage level during power - up sequence delay (see 图 9-2) | | 6 | V |
| VBIAS | Supply voltage level during power - up sequence delay (see 图 9-2) | | 6 | V |



Refer to $\frac{1}{8}$ 9-1 for VOFFSET and VBIAS supply voltage levels during power-up sequence delay.

图 9-2. Power-Up Sequence Delay Requirement



10 Layout

10.1 Layout Guidelines

There are no specific layout guidelines for the DMD as typically DMD is connected using a board to board connector to a flex cable. Flex cable provides the interface of data and Ctrl signals between the DLPC3479 controller and the DLP4710LC DMD. For detailed layout guidelines refer to the layout design files. Some layout guideline for the flex cable interface with DMD are:

- Match lengths for the LS_WDATA and LS_CLK signals.
- Minimize vias, layer changes, and turns for the HS bus signals. Refer 🛭 10-1.
- Minimum of two 220-nF decoupling capacitor close to VBIAS. Capacitor C3 and C10 in 🛭 10-1.
- Minimum of two 220-nF decoupling capacitor close to VRST. Capacitor C1 and C9 in 🛭 10-1.
- Minimum of two 220-nF decoupling capacitor close to VOFS. Capacitor C2 and C8 in 图 10-1.
- Minimum of four 220-nF decoupling capacitor close to VDDI and VDD. Capacitor C4, C5, C6 and C7 in \$\text{\tilde{\text{\texi{\text{\text{\texi}\text{\text{\text{\text{\text{\text{\texi{\text{\texi{\texi{\texi{\texi{\texi{\texi{\texi{\texi{\texi}\texi{\texi{\texi{\texi{\texi{\texi{

10.2 Layout Example

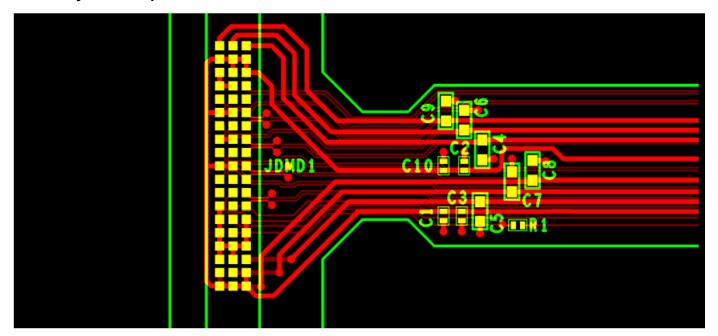


图 10-1. Power Supply Connections



11 Device and Documentation Support

11.1 Device Support

11.1.1 第三方产品免责声明

TI 发布的与第三方产品或服务有关的信息,不能构成与此类产品或服务或保修的适用性有关的认可,不能构成此类产品或服务单独或与任何 TI 产品或服务一起的表示或认可。

11.1.2 Device Nomenclature



图 11-1. Part Number Description

11.1.3 Device Markings

The device marking includes the legible character string GHJJJK DLP4710AFQL. GHJJJJK is the lot trace code. DLP4710AFQL is the device marking.

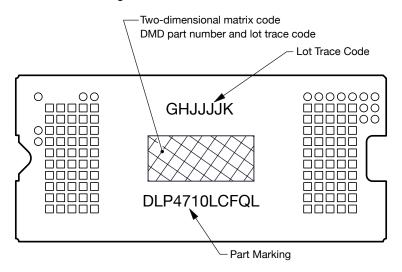


图 11-2. DMD Marking Locations

11.2 Related Links

The table below lists quick access links. Categories include technical documents, support and community resources, tools and software, and quick access to sample or buy.

TECHNICAL TOOLS & SUPPORT & **PARTS** PRODUCT FOLDER **SAMPLE & BUY DOCUMENTS SOFTWARE** COMMUNITY **DLPC3479** Click here Click here Click here Click here Click here **DLPA3000** Click here Click here Click here Click here Click here **DLPA3005** Click here Click here Click here Click here Click here

表 11-1. Related Links



11.3 接收文档更新通知

要接收文档更新通知,请导航至 ti.com 上的器件产品文件夹。点击*订阅更新* 进行注册,即可每周接收产品信息更改摘要。有关更改的详细信息,请查看任何已修订文档中包含的修订历史记录。

11.4 支持资源

TI E2E™ 支持论坛是工程师的重要参考资料,可直接从专家获得快速、经过验证的解答和设计帮助。搜索现有解答或提出自己的问题可获得所需的快速设计帮助。

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11.6 静电放电警告



静电放电 (ESD) 会损坏这个集成电路。德州仪器 (TI) 建议通过适当的预防措施处理所有集成电路。如果不遵守正确的处理和安装程序,可能会损坏集成电路。

ESD 的损坏小至导致微小的性能降级,大至整个器件故障。精密的集成电路可能更容易受到损坏,这是因为非常细微的参数更改都可能会导致器件与其发布的规格不相符。

11.7 术语表

TI术语表本术语表列出并解释了术语、首字母缩略词和定义。

12 Mechanical, Packaging, and Orderable Information

The following pages include mechanical, packaging, and orderable information. This information is the most current data available for the designated devices. This data is subject to change without notice and revision of this document. For browser-based versions of this data sheet, refer to the left-hand navigation.

Product Folder Links: DLP4710LC

English Data Sheet: DLPS178

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PACKAGING INFORMATION

| Orderable part number | Status | Material type | Package Pins | Package qty Carrier | RoHS | Lead finish/ Ball material | MSL rating/ Peak reflow | Op temp (°C) | Part marking (6) |
|-----------------------|--------|---------------|------------------|--------------------------|------|-------------------------------|----------------------------|--------------|------------------|
| | | | | | | (4) | (5) | | |
| DLP4710LCFQL | Active | Production | CLGA (FQL) 100 | 80 JEDEC TRAY (5+1) | Yes | NI/AU | N/A for Pkg Type | 0 to 70 | |
| DLP4710LCFQL.B | Active | Production | CLGA (FQL) 100 | 80 JEDEC TRAY (5+1) | Yes | NI/AU | N/A for Pkg Type | 0 to 70 | |

⁽¹⁾ Status: For more details on status, see our product life cycle.

Multiple part markings will be inside parentheses. Only one part marking contained in parentheses and separated by a "~" will appear on a part. If a line is indented then it is a continuation of the previous line and the two combined represent the entire part marking for that device.

Important Information and Disclaimer: The information provided on this page represents TI's knowledge and belief as of the date that it is provided. TI bases its knowledge and belief on information provided by third parties, and makes no representation or warranty as to the accuracy of such information. Efforts are underway to better integrate information from third parties. TI has taken and continues to take reasonable steps to provide representative and accurate information but may not have conducted destructive testing or chemical analysis on incoming materials and chemicals. TI and TI suppliers consider certain information to be proprietary, and thus CAS numbers and other limited information may not be available for release.

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⁽²⁾ Material type: When designated, preproduction parts are prototypes/experimental devices, and are not yet approved or released for full production. Testing and final process, including without limitation quality assurance, reliability performance testing, and/or process qualification, may not yet be complete, and this item is subject to further changes or possible discontinuation. If available for ordering, purchases will be subject to an additional waiver at checkout, and are intended for early internal evaluation purposes only. These items are sold without warranties of any kind.

⁽³⁾ RoHS values: Yes, No, RoHS Exempt. See the TI RoHS Statement for additional information and value definition.

⁽⁴⁾ Lead finish/Ball material: Parts may have multiple material finish options. Finish options are separated by a vertical ruled line. Lead finish/Ball material values may wrap to two lines if the finish value exceeds the maximum column width.

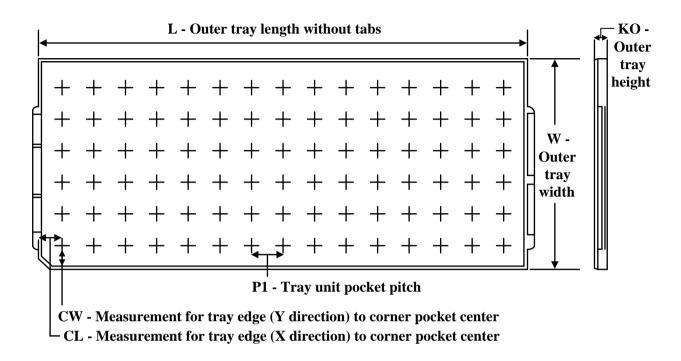
⁽⁵⁾ MSL rating/Peak reflow: The moisture sensitivity level ratings and peak solder (reflow) temperatures. In the event that a part has multiple moisture sensitivity ratings, only the lowest level per JEDEC standards is shown. Refer to the shipping label for the actual reflow temperature that will be used to mount the part to the printed circuit board.

⁽⁶⁾ Part marking: There may be an additional marking, which relates to the logo, the lot trace code information, or the environmental category of the part.



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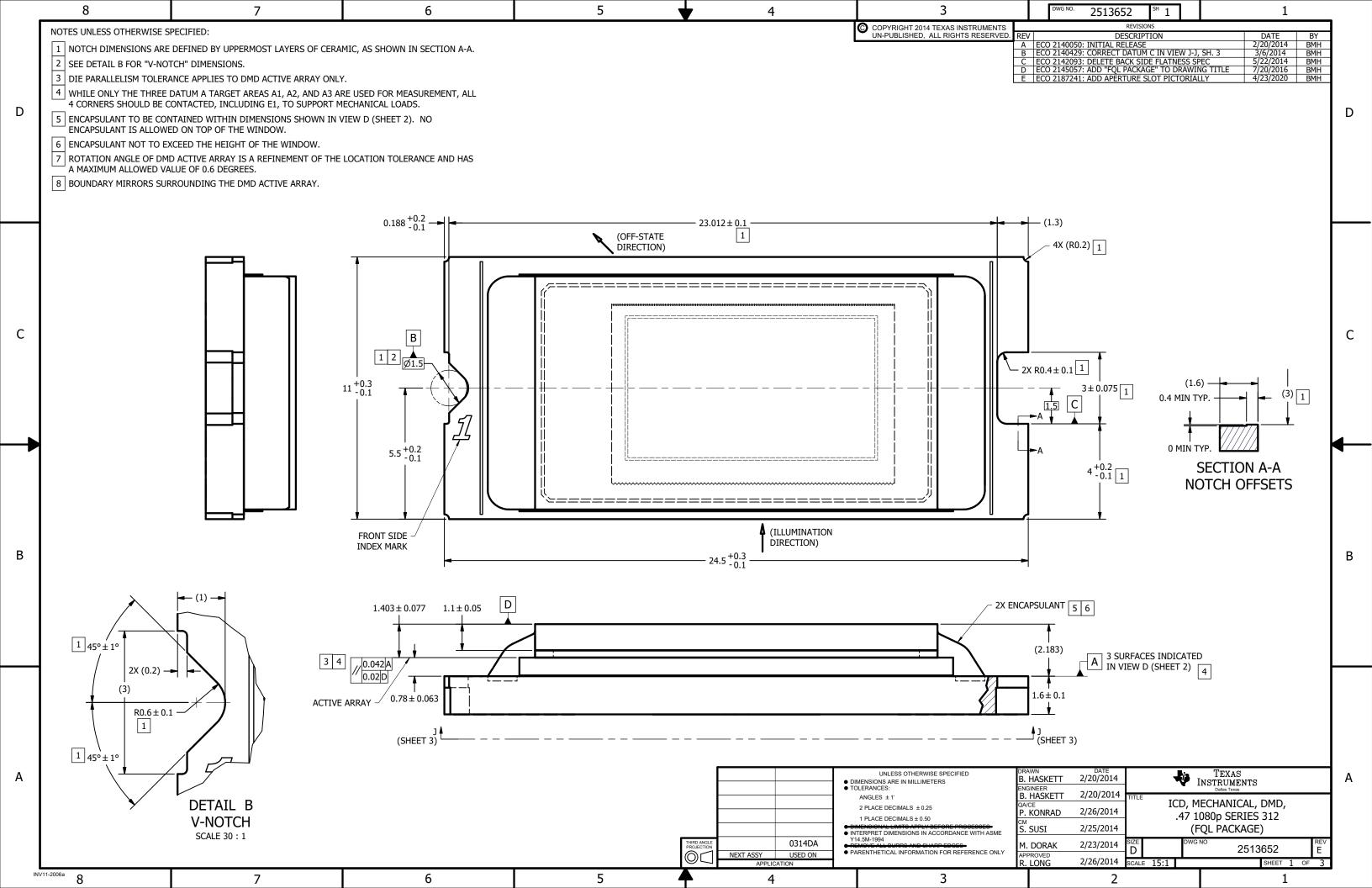
TRAY

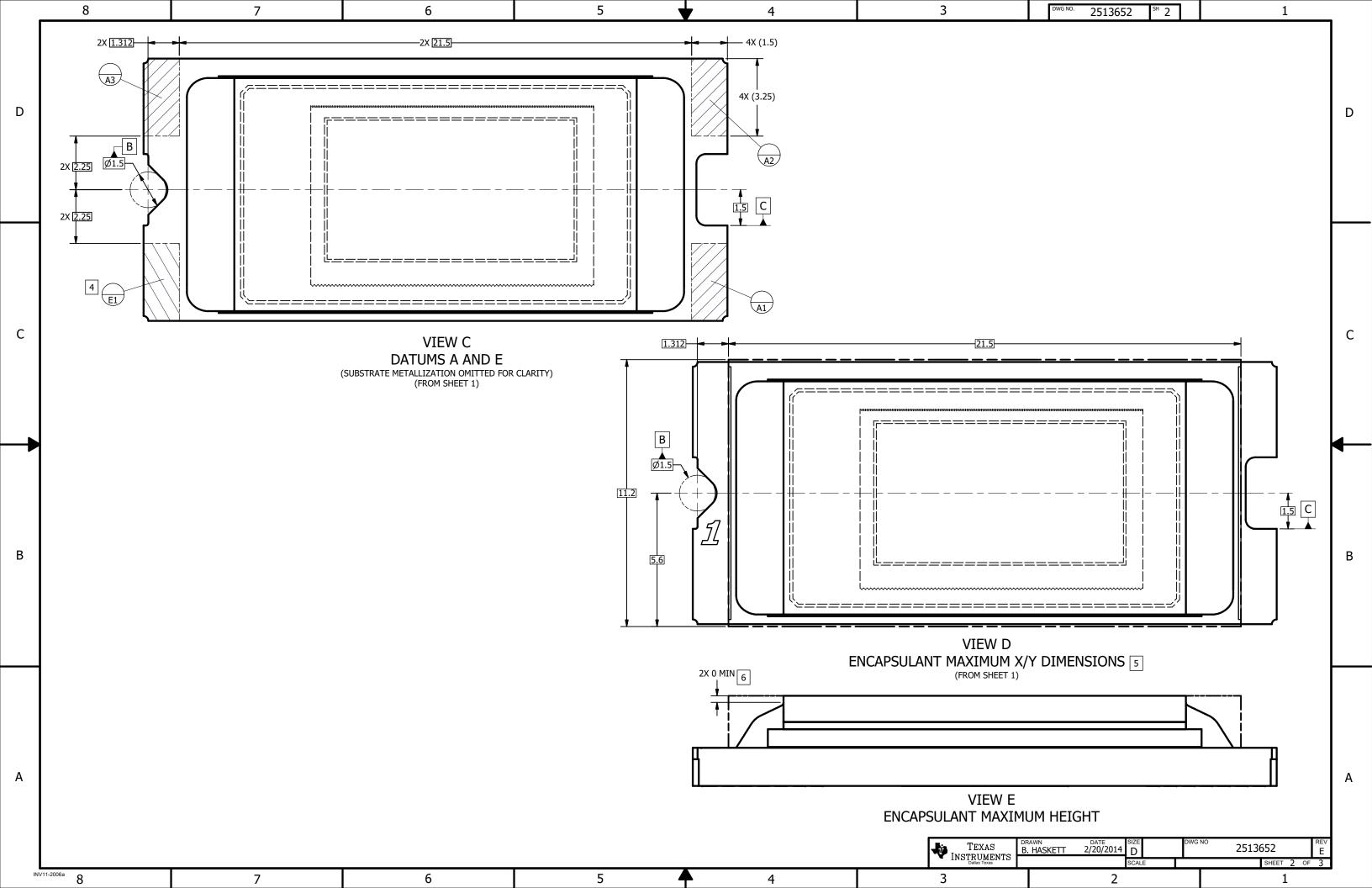


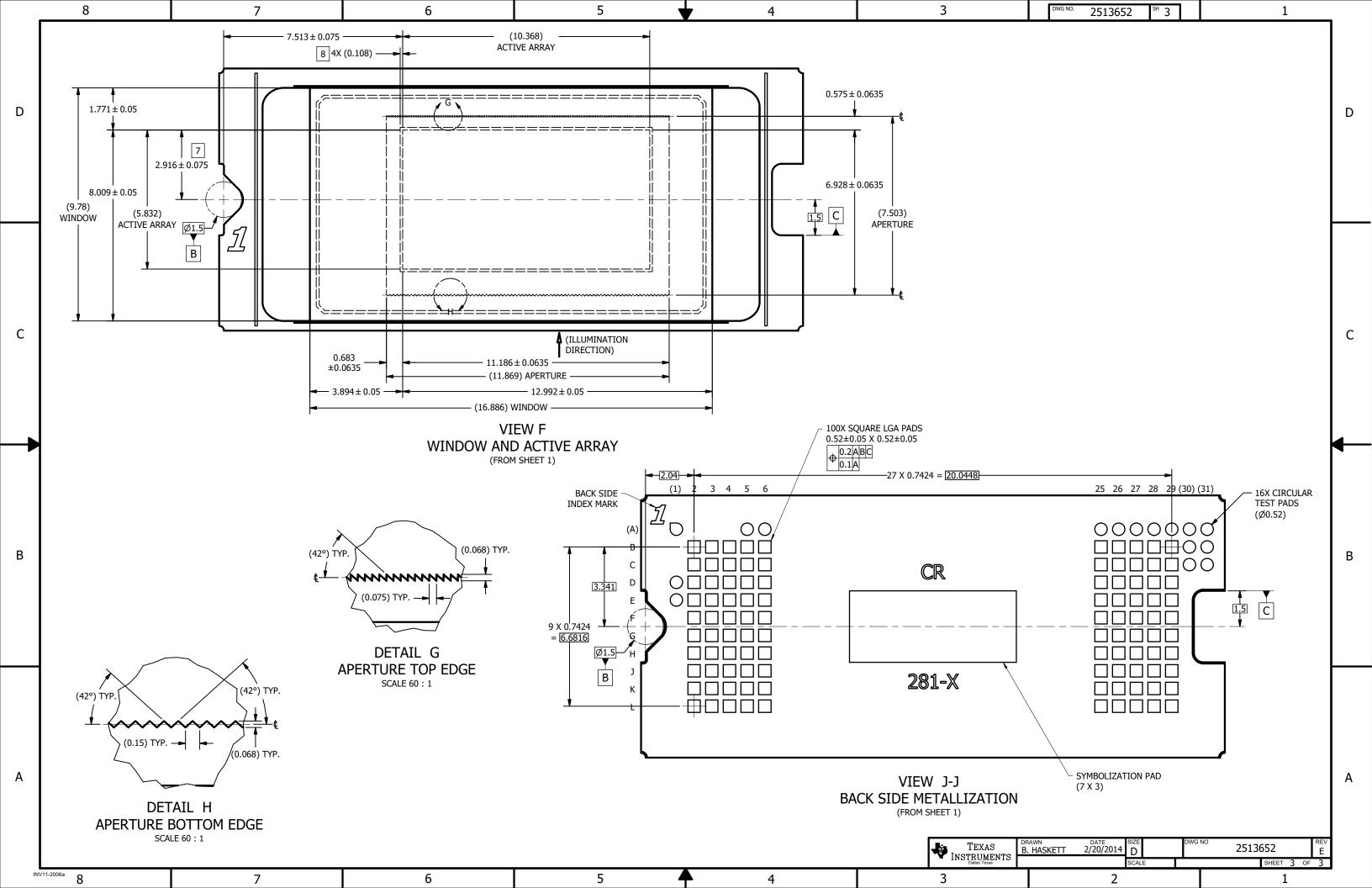
Chamfer on Tray corner indicates Pin 1 orientation of packed units.

*All dimensions are nominal

| Device | Package Name | Package Type | Pins | SPQ | Unit array matrix | Max temperature (°C) | L (mm) | W (mm) | Κ0 (μm) | P1 (mm) | CL (mm) | CW (mm) |
|----------------|-----------------|-----------------|------|-----|----------------------|----------------------------|--------|-----------|------------|------------|------------|------------|
| DLP4710LCFQL | FQL | CLGA | 100 | 80 | 8 x 10 | 150 | 315 | 135.9 | 12190 | 28 | 31.5 | 15.45 |
| DLP4710LCFQL.B | FQL | CLGA | 100 | 80 | 8 x 10 | 150 | 315 | 135.9 | 12190 | 28 | 31.5 | 15.45 |







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